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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	NOT YET ASSIGNED 401586445
		Filing Date	July 17, 2006
		First Named Inventor	KOZO NAKAMURA ET AL.
		Art Unit	NOT YET ASSIGNED
		Examiner Name	NOT YET ASSIGNED
Sheet 1 of 1	Attorney Docket Number	1110/97825	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS						
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		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	1	JP 2003-257983	09-12-2003	Shin Etsu Handotai Co Ltd.		
	2	JP 2000-068280	03-03-2000	Sumitomo Metal Ind Ltd.		
	3	JP 2003-318181	11-07-2003	Sumitomo Mitsubishi Silicon Corp		
	4	JP 11-147789	06-02-1999	Shin Etsu Handotai Co Ltd.		
	5	JP 02-263792	10-26-1990	Shin Etsu Handotai Co Ltd.		
	6	JP 04-130732	05-01-1992	Komatsu Electron Metals Co Ltd.		
	7	JP 04-298042	10-21-1992	Komatsu Electron Metals Co Ltd.		
	8	JP 04-174300	06-23-1992	Toshiba Ceramics Co Ltd.		
	9	JP 05-102167	04-23-1993	Shin Etsu Handotai Co Ltd.		

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ⁶
	10	Hiroshi TAKENO et al, article entitled "Practical Computer Simulation Technique To Predict Oxygen Precipitation Behavior In Czochralski Silicon Wafers For Various Thermal Processes," (Journal of Electrochemical Society, 1997, Vol. 144, No. 12, pp. 4340-4345 (the citation in ISR))	
	11	Koji SUEOKA et al., article entitled "Computer Simulation For Morphology, Size, and Density of Oxide Precipitates in CZ Silicon," (Journal of Electrochemical Society, 2003, Vol. 150, pp. G469-G475.)	
	12	M. Schrems, article entitled "Simulation of Oxygen Precipitation," (Semiconductors and Semimetals, 1994, Vol. 42, pp. 391-447) (Copyright © 1994 by Academic Press, Inc.)	

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